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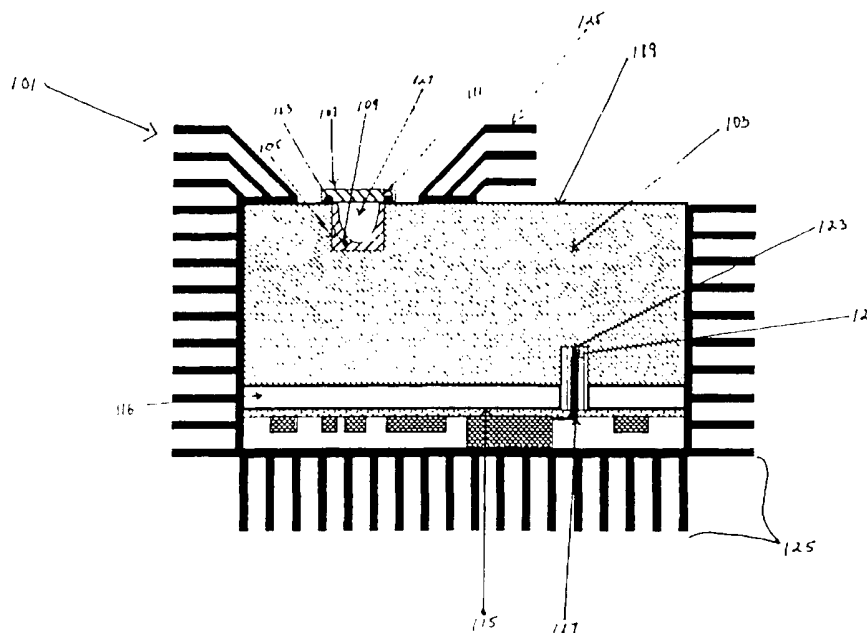
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(54) Title: **PLASMA LAMP WITH DIELECTRIC WAVEGUIDE**



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DESCRIPTIONPlasma Lamp With Dielectric Waveguide

This application claims priority to a U.S. Provisional Application entitled "Plasma Lamp," having Serial No. 60/222,028 and filed on July 31, 2000, and a
5 U.S. Application entitled "Plasma Lamp with Dielectric Waveguide," having Serial No. 09/809,718 and filed on March 15, 2001, both of which are hereby incorporated by reference as though fully set forth herein.

Background Of The Invention1. Field of the Invention

10 The field of the present invention relates to devices and methods for generating light, and more particularly to electrodeless plasma lamps.

2. Background

Electrodeless plasma lamps provide point-like, bright, white light sources. Because they do not use electrodes, electrodeless plasma lamps often have
15 longer useful lifetimes than other lamps. Electrodeless plasma lamps in the prior art have certain common features. For example in U.S. Patent Nos. 4,954,755 to Lynch et al., 4,975,625 to Lynch et al., 4,978,891 to Ury et al., 5,021,704 to Walter et al., 5,448,135 to Simpson, 5,594,303 to Simpson, 5,841,242 to Simpson et al., 5,910,710 to Simpson, and 6,031,333 to Simpson, each of which is incorporated
20 herein by reference, the plasma lamps direct microwave energy into an air cavity, with the air cavity enclosing a bulb containing a mixture of substances that can ignite, form a plasma, and emit light.

The plasma lamps described in these patents are intended to provide brighter light sources with longer life and more stable spectrum than electrode
25 lamps. However, for many applications, light sources that are brighter, smaller, less expensive, more reliable, and have long useful lifetimes are desired, but such light sources until now have been unavailable. Such applications include, for example, streetlights and emergency response vehicles. A need exists therefore, for a very bright, durable light source at low cost.

30 In the prior art, the air-filled cavity of the electrodeless plasma lamp is typically constructed in part by a metal mesh. Metal mesh is used because it contains the microwave energy within the cavity while at the same time permitting

the maximum amount of visible light to escape. The microwave energy is typically generated by a magnetron or solid state electronics and is guided into the cavity through one or more waveguides. Once in the air-filled cavity, microwave energy of select frequencies resonates, where the actual frequencies that resonate depend upon the shape and size of the cavity. Although there is tolerance in the frequencies that may be used to power the lamps, in practice, the power sources are limited to microwave frequencies in the range of 1-10 GHz.

Because of the need to establish a resonance condition in the air-filled cavity, the cavity generally may not be smaller than one-half the wavelength of the microwave energy used to power the lamp. The air-filled cavity and thereby, the plasma lamp itself has a lower limit on its size. However, for many applications, such as for high-resolution monitors, bright lamps, and projection TVs, these sizes remain prohibitively large. A need exists therefore for a plasma lamp that is not constrained to the minimum cavity sizes illustrated by the prior art.

In the prior art, the bulbs are typically positioned at a point in the cavity where the electric field created by the microwave energy is at a maximum. The support structure for the bulb is preferably of a size and composition that does not interfere with the resonating microwaves, as any interference with the microwaves reduces the efficiency of the lamp. The bulbs, therefore, are typically made from quartz. Quartz bulbs, however, are prone to failure because the plasma temperature can be several thousand degrees centigrade, which can bring the quartz wall temperature to near 1000°C. Furthermore, quartz bulbs are unstable in terms of mechanical stability and optical and electrical properties over long periods. A need exists, therefore, for a light source that overcomes the above-described issues, but that is also stable in its spectral characteristics over long periods.

In prior art plasma lamps, the bulb typically contains a noble gas combined with a light emitter, a second element or compound which typically comprises sulfur, selenium, a compound containing sulfur or selenium, or any one of a number of metal halides. Exposing the contents of the bulb to microwave energy of high intensity causes the noble gas to become a plasma. The free electrons within the plasma excite the light emitter within the bulb. When the light emitter returns to a lower electron state, radiation is emitted. The spectrum of light emitted depends upon the characteristics of the light emitter within the bulb. Typically, the light emitter is chosen to cause emission of visible light.

Plasma lamps of the type described above frequently require high intensity microwaves to initially ignite the noble gas into plasma. However, over half of the energy used to generate and maintain the plasma is typically lost as heat, making heat dissipation a problem. Hot spots can form on the bulb causing spotting on the bulb and thereby reducing the efficiency of the lamp. Methods have been proposed to reduce the hot spots by rotating the lamp to better distribute the plasma within the lamp and by blowing constant streams of air at the lamp. These solutions, however, add structure to the lamp, thereby increasing its size and cost. Therefore, a need exists for a plasma lamp that requires less energy to ignite and maintain the plasma, and includes a minimum amount of additional structure for efficient dissipation of heat.

Summary Of The Invention

This invention generally provides, in one aspect, devices and methods of producing bright, spectrally stable light.

In accordance with one embodiment as described herein, a device for producing light comprises an electromagnetic energy source, a waveguide having a body formed of a dielectric material, and a bulb. Preferably, the waveguide is connected to the energy source for receiving electromagnetic energy from the energy source. The waveguide builds and contains the electromagnetic energy. The bulb, which is coupled to the waveguide, receives electromagnetic energy from the waveguide. The received electromagnetic energy ignites a gas-fill that forms a plasma and emits light, preferably in the visible spectral range.

In one preferred embodiment, the bulb is shaped to reflect light outwards through its window. The electromagnetic energy source is preferably a microwave energy source that is efficiently coupled to and preferably thermally isolated from the waveguide. Furthermore, the outer surface of the waveguide, preferably with the exception of the bulb cavity, is coated with a material to contain the microwave energy within the waveguide. The dielectric forming the waveguide preferably has a high dielectric constant, a high dielectric strength, and a low loss tangent. This permits high power densities within the waveguide. A heat sink preferably is attached to the outer surfaces of the waveguide to dissipate heat.

In accordance with a first alternative embodiment, the lamp is operated in resonant cavity mode. In this mode, the microwave energy directed into the waveguide has a frequency such that it resonates within the waveguide. The

microwave feed and the bulb are preferably positioned at locations with respect to the waveguide that correspond to electric field maxima of the resonant frequency.

In accordance with a second alternative embodiment, the lamp is operated in a dielectric oscillator mode. In this mode, an energy feedback mechanism or probe is coupled to the dielectric waveguide at a point that in one embodiment corresponds to an energy maximum. The probe senses the electric field amplitude and phase within the waveguide at the point of coupling. Using the probe signal to provide feedback, the lamp may be continuously operated in resonant cavity mode, even if the resonant frequency changes as the plasma forms in the bulb and/or if the dielectric waveguide undergoes thermal expansion due to the heat generated. The probe provides feedback to the microwave source and the microwave source adjusts its output frequency to dynamically maintain a resonance state.

Further embodiments, variations and enhancements, including combinations of the above-described embodiments, or features thereof, are also described herein or depicted in the accompanying drawings.

Brief Description Of The Drawings

FIG. 1 illustrates a sectional view of a plasma lamp according to a preferred embodiment.

FIGS. 2A and 2B illustrate sectional views of alternative embodiments of a plasma lamp.

FIGS. 3A and 3B illustrate a sectional view of an alternative embodiment of a plasma lamp wherein the bulb is thermally isolated from the dielectric waveguide.

FIGS. 4A-D illustrate different resonant modes within a rectangular prism-shaped waveguide.

FIGS. 5A-C illustrate different resonant modes within using a cylindrical prism-shaped cylindrical waveguide.

FIG. 6 illustrates an embodiment of the apparatus using a feedback mechanism to provide feedback to the microwave source to maintain a resonant mode of operation.

Detailed Description Of The Preferred Embodiments

Turning now to the drawings, FIG. 1 illustrates a preferred embodiment of a dielectric waveguide integrated plasma lamp 101 (DWIPL). The DWIPL 101

preferably comprises a source 115 of electromagnetic radiation, preferably microwave radiation, a waveguide 103 having a body formed of a dielectric material, and a feed 117 coupling the radiation source 115 to the waveguide 103. As used herein, the term "waveguide" generally refers to any device having a characteristic and purpose of at least partially confining electromagnetic energy. The DWIPL 101 further includes a bulb 107, that is preferably disposed on an opposing side of the waveguide 103, and contains a gas-fill, preferably comprising a noble gas and a light emitter, which when receiving electromagnetic energy at a specific frequency and intensity forms a plasma and emits light.

10 In a preferred embodiment, the microwave radiation source 115 feeds the waveguide 103 microwave energy via the feed 117. The waveguide contains and guides the microwave energy to a cavity 105 preferably located on an opposing side of the waveguide 103 from the feed 117. Disposed within the cavity 105 is the bulb 107 containing the gas-fill. Microwave energy is preferably directed into
15 the enclosed cavity 105, and in turn the bulb 107. This microwave energy generally frees electrons from their normal state and thereby transforms the noble gas into a plasma. The free electrons of the noble gas excite the light emitter. The de-excitation of the light emitter results in the emission of light. As will become apparent, the different embodiments of DWIPLs disclosed herein offer
20 distinct advantages over the plasma lamps in the prior art, such as an ability to produce brighter and spectrally more stable light, greater energy efficiency, smaller overall lamp sizes, and longer useful life spans.

The microwave source 115 in FIG. 1 is shown schematically as solid state electronics, however, other devices commonly known in the art that can operate in
25 the 0.5 - 30 GHz range may also be used as a microwave source, including but not limited to klystrons and magnetrons. The preferred range for the microwave source is from about 500 MHz to about 10 GHz.

Depending upon the heat sensitivity of the microwave source 115, the microwave source 115 may be thermally isolated from the bulb 107, which during
30 operation preferably reaches temperatures between about 700 °C and about 1000 °C. Thermal isolation of the bulb 107 from the source 115 provides a benefit of avoiding degradation of the source 115. Additional thermal isolation of the microwave source 115 may be accomplished by any one of a number of methods commonly known in the art, including but not limited to using an insulating material
35 or vacuum gap occupying an optional space 116 between the source 115 and

waveguide 103. If the latter option is chosen, appropriate microwave feeds are used to couple the microwave source 115 to the waveguide 103.

In FIG. 1, the feed 117 that transports microwaves from the source 115 to the waveguide 103 preferably comprises a coaxial probe. However, any one of
5 several different types of microwave feeds commonly known in the art may be used, such as microstrip lines or fin line structures.

Due to mechanical and other considerations such as heat, vibration, aging, or shock, when feeding microwave signals into a dielectric material, contact between the feed 117 and the waveguide 103 is preferably maintained using a
10 positive contact mechanism 121. The contact mechanism 121 provides constant pressure between the feed 117 and the waveguide 103 to minimize the probability that microwave energy will be reflected back through the feed 117 and not transmitted into the waveguide 103. In providing constant pressure, the contact
15 mechanism 121 compensates for small dimensional changes in the microwave feed 117 and the waveguide 103 that may occur due to thermal heating or mechanical shock. The contact mechanism may be a spring loaded device, such as is illustrated in FIG. 1, a bellows type device, or any other device commonly known in the art that can sustain a constant pressure for continuously and steadily
20 transferring microwave energy.

When coupling the feed 117 to the waveguide 103, intimate contact is preferably made by depositing a metallic material 123 directly on the waveguide 103 at its point of contact with the feed 117. The metallic material 123 eliminates gaps that may disturb the coupling and is preferably comprised of gold, silver, or platinum, although other conductive materials may also be used. The metallic
25 material 123 may be deposited using any one of several methods commonly known in the art, such as depositing the metallic material 123 as a liquid and then firing it in an oven to provide a solid contact.

In FIG. 1, the waveguide 103 is preferably the shape of a rectangular prism, however, the waveguide 103 may also have a cylindrical prism shape, a
30 sphere-like shape, or any other shape, including a complex, irregular shape the resonant frequencies of which are preferably determined through electromagnetic simulation tools, that can efficiently guide microwave energy from the feed 117 to the bulb 107. The actual dimensions of the waveguide may vary depending upon the frequency of the microwave energy used and the dielectric constant of the
35 body of waveguide 103.

In one preferred embodiment, the waveguide body is approximately 12,500 mm³ with a dielectric constant of approximately 9 and operating frequency of approximately 2.4 GHz. Waveguide bodies on this scale are significantly smaller than the waveguides in the plasma lamps of the prior art. As such, the waveguides in the preferred embodiments represent a significant advance over the prior art because the smaller size allows the waveguide to be used in many applications, where waveguide size had previously prohibited such use or made such use wholly impractical. For larger dielectric constants, even smaller sizes for the waveguides may be achieved. Besides the obvious advantages created by a reduction in size, size reduction translates into a higher power density, lower loss, and thereby, an ease in igniting the lamp.

Regardless of its shape and size, the waveguide 103 preferably has a body comprising a dielectric material which, for example, preferably exhibits the following properties: (1) a dielectric constant preferably greater than approximately 2; (2) a loss tangent preferably less than approximately 0.01; (3) a thermal shock resistance quantified by a failure temperature of preferably greater than approximately 200°C; (4) a DC breakdown threshold of preferably greater than approximately 200 kilovolts/inch; (5) a coefficient of thermal expansion of preferably less than approximately 10⁻⁵/°C; (6) a zero or slightly negative temperature coefficient of the dielectric constant; (7) stoichiometric stability over a preferred range of temperature, preferably from about -80 °C to about 1000 °C, and (8) a thermal conductivity of preferably approximately 2 W/mK (watts per milliKelvin).

Certain ceramics, including alumina, zirconia, titanates, and variants or combinations of these materials, and silicone oil may satisfy many of the above preferences, and may be used because of their electrical and thermo-mechanical properties. In any event, it should be noted that the embodiments presented herein are not limited to a waveguide exhibiting all or even most of the foregoing properties.

In the various embodiments of the waveguide disclosed herein, such as in the example outlined above, the waveguide preferably provides a substantial thermal mass, which aids efficient distribution and dissipation of heat and provides thermal isolation between the lamp and the microwave source.

Alternative embodiments of DWIPLS 200, 220 are depicted in FIGS. 2A-B. In Fig. 2A, a bulb 207 and bulb cavity 205 are provided on one side of a waveguide 203, preferably on a side opposite a feed 209, and more preferably in

the same plane as the feed 209, where the electric field of the microwave energy is at a maximum. Where more than one maximum of the electric field is provided in the waveguide 203, the bulb 207 and bulb cavity 205 may be positioned at one maximum and the feed 209 at another maximum. By placing the feed 209 and
5 bulb 207 at a maximum for the electric field, a maximum amount of energy is respectively transferred and intercepted. The bulb cavity 205 is a concave form in the body of the waveguide 203.

As shown in FIG. 2B, the body of the waveguide 223 optionally protrudes outwards in a convex form, from the main part of the body of the waveguide 203
10 to form the bulb cavity 225. As in FIG. 2A, in FIG. 2B, the bulb 227 is preferably positioned opposite to the feed 221. However, where more than one electric field maximum is provided in the waveguide 203, the bulb 207, 227 may be positioned in a plane other than the plane of the feed 209, 221.

Returning to FIG. 1, the outer surfaces of the waveguide 103, with the
15 exception of those surfaces forming the bulb cavity 105, are preferably coated with a thin metallic coating 119 to reflect the microwaves. The overall reflectivity of the coating 119 determines the level of energy contained within the waveguide 103. The more energy that can be stored within the waveguide 103, the greater the overall efficiency of the lamp 101. The coating 119 also preferably
20 suppresses evanescent radiation leakage. In general, the coating 119 preferably significantly eliminates any stray microwave field.

Microwave leakage from the bulb cavity 105 may be significantly attenuated by having a cavity 105 that is preferably significantly smaller than the microwave wavelengths used to operate the lamp 101. For example, the length of
25 the diagonal for the window is preferably considerably less than half of the microwave wavelength (in free space) used.

The bulb 107 is disposed within the bulb cavity 105, and preferably comprises an outer wall 109 and a window 111. In one preferred embodiment, the cavity wall of the body of the waveguide 103 acts as the outer wall of the bulb
30 107. The components of the bulb 107 preferably include one or more dielectric materials, such as ceramics and sapphires. In one embodiment, the ceramics in the bulb are the same as the material used in waveguide 103. Dielectric materials are preferred for the bulb 107 because the bulb 107 is preferably surrounded by the dielectric body of the waveguide 103 and the dielectric materials help ensure
35 efficient coupling of the microwave energy with the gas-fill in the bulb 107.

The outer wall 109 is preferably coupled to the window 111 using a seal 113, thereby defining a bulb envelope 127 which contains the gas-fill comprising the plasma-forming gas and light emitter. The plasma-forming gas is preferably a noble gas, which enables the formation of a plasma. The light emitter is preferably a vapor formed of any one of a number of elements or compounds currently known in the art, such as sulfur, selenium, a compound containing sulfur or selenium, or any one of a number of metal halides, such as indium bromide (InBr_3).

To assist in confining the gas-fill within the bulb 107, the seal 113 preferably comprises a hermetic seal. The outer wall 109 preferably comprises alumina because of its white color, temperature stability, low porosity, and thermal expansion coefficient. However, other materials that generally provide one or more of these properties may be used. The outer wall 109 is also preferably contoured to reflect a maximum amount of light out of the cavity 105 through the window 111. For instance, the outer wall 109 may have a parabolic contour to reflect light generated in the bulb 107 out through the window 111. However, other outer wall contours or configurations that facilitate directing light out through the window 111 may be used.

The window 111 preferably comprises sapphire for light transmittance and because its thermal expansion coefficient matches well with alumina. Other materials that have a similar light transmittance and thermal expansion coefficient may be used for the window 111. In an alternative embodiment, the window 111 may comprise a lens to collect the emitted light.

As referenced above, during operation, the bulb 107 may reach temperatures of up to about 1000 °C. Under such conditions, the waveguide 103 in one embodiment acts as a heat sink for the bulb 107. By reducing the heat load and heat-induced stress upon the various components of the DWIPL 101, the useful life span of the DWIPL 101 is generally increased beyond the life span of typical electrodeless lamps. Effective heat dissipation may be obtained by preferably placing heat-sinking fins 125 around the outer surfaces of the waveguide 103, as depicted in FIG. 1. In the embodiment shown in FIG. 2B, with the cavity 225 extending away from the main part of the body of the waveguide 223, the DWIPL 220 may be used advantageously to remove heat more efficiently by placing fins 222 in closer proximity to the bulb 227.

In another embodiment, the body of the waveguide 103 comprises a dielectric, such as a titanate, which is generally not stable at high temperatures.

In this embodiment, the waveguide 103 is preferably shielded from the heat generated in the bulb 107 by placing a thermal barrier between the body of the waveguide 103 and the bulb 107. In one alternative embodiment, the outer wall 109 acts as a thermal barrier by comprising a material with low thermal conductivity such as NZP. Other suitable material for a thermal barrier may also be used.

FIGS. 3A and 3B illustrate an alternative embodiment of a DWIPL 300 wherein a vacuum gap acts as a thermal barrier. As shown in FIG. 3A, the bulb 313 of the DWIPL 300 is disposed within a bulb cavity 315 and is separated from the waveguide 311 by a gap 317, the thickness of which preferably varies depending upon the microwave propagation characteristics and material strength of the material used for the body of the waveguide 311 and the bulb 313. The gap 317 is preferably a vacuum, minimizing heat transfer between the bulb 313 and the waveguide 311.

FIG. 3B illustrates a magnified view of the bulb 313, bulb cavity 315, and vacuum gap 317 for the DWIPL 300. The boundaries of the vacuum gap 317 are formed by the waveguide 311, a bulb support 319, and the bulb 313. The bulb support 319 may be sealed to the waveguide 311, the support 319 extending over the edges of the bulb cavity 315 and comprising a material such as alumina that preferably has high thermal conductivity to help dissipate heat from the bulb 313.

Embedded in the support 319 is an access seal 321 for establishing a vacuum within the gap 317 when the bulb 313 is in place. The bulb 313 is preferably supported by and hermetically sealed to the bulb support 319. Once a vacuum is established in the gap 317, heat transfers between the bulb 313 and the waveguide 311 are preferably substantially reduced.

Embodiments of the DWIPLs thus far described preferably operate at a microwave frequency in the range of 0.5 - 10 GHz. The operating frequency preferably excites one or more resonant modes supported by the size and shape of the waveguide, thereby establishing one or more electric field maxima within the waveguide. When used as a resonant cavity, at least one dimension of the waveguide is preferably an integer number of half-wavelengths long.

FIGS. 4A-C illustrate three alternative embodiments of DWIPLs 410, 420, 430 operating in different resonant modes. FIG. 4A illustrates a DWIPL 410 operating in a first resonant mode 411 where one axis of a rectangular prism-shaped waveguide 417 has a length that is one-half the wavelength of the microwave energy used. FIG. 4B illustrates a DWIPL 420 operating in a resonant

mode 421 where one axis of a rectangular prism-shaped waveguide 427 has a length that is equal to one wavelength of the microwave energy used. FIG. 4C illustrates a DWIPL 430 operating in a resonant mode 431 where one axis of a rectangular prism-shaped waveguide 437 has a length that is $1\frac{1}{2}$ wavelengths of the microwave energy used.

In each of the DWIPLs and corresponding modes depicted in FIGS. 4A-C, and for DWIPLs operating at any higher modes, the bulb cavity 415, 425, 435 and the feed(s) 413, 423, 433, 434 are preferably positioned with respect to the waveguide 417, 427, 437 at locations where the electric fields are at an operational maximum. However, the bulb cavity and the feed do not necessarily have to lie in the same plane.

FIG. 4C illustrates an additional embodiment of a DWIPL 430 wherein two feeds 433, 434 are used to supply energy to the waveguide 437. The two feeds 433, 434 may be coupled to a single microwave source or multiple sources (not shown).

FIG. 4D illustrates another embodiment wherein a single energy feed 443 supplies energy into the waveguide 447 having multiple bulb cavities 415, 416, each positioned with respect to the waveguide 447 at locations where the electric field is at a maximum.

FIGS. 5A-C illustrate DWIPLs 510, 520, 530 having cylindrical prism-shaped waveguides 517, 527, 537. In the embodiments depicted in FIGS. 5A-C, the height of the cylinder is preferably less than its diameter, the diameter preferably being close to an integer multiple of the lowest order half-wavelength of energy that can resonate within the waveguide 517, 527, 537. Placing such a dimensional restriction on the cylinder results in the lowest resonant mode being independent of the height of the cylinder. The diameter of the cylinder thereby dictates the fundamental mode of the energy within the waveguide 517, 527, 537. The height of the cylinder can therefore be optimized for other requirements such as size and heat dissipation. In FIG. 5A, the feed 513 is preferably positioned directly opposite the bulb cavity 515 and the zeroeth order Bessel mode 511 is preferably excited.

Other modes may also be excited within a cylindrical prism-shaped waveguide. For example, FIG. 5B illustrates a DWIPL 520 operating in a resonant mode where the cylinder 527 has a diameter that is preferably close to one wavelength of the microwave energy used.

As another example, FIG. 5C illustrates a DWIPL 520 operating in a resonant mode where the cylinder 537 has a diameter that is preferably close to $\frac{1}{2}$ wavelengths of the microwave energy used. FIG. 5C additionally illustrates an embodiment of a DWIPL 530 whereby two feeds 533, 534 are used to supply energy to the cylinder-shaped waveguide 537. As with other embodiments of the DWIPL, in a DWIPL having a cylinder-shaped waveguide, the bulb cavity 515, 525, 535 and the feed(s) 513, 523, 533, 534 are preferably positioned with respect to the waveguide 517, 527, 537 at locations where the electric field is at a maximum.

Using a dielectric waveguide has several distinct advantages. First, as discussed above, the waveguide may be used to help dissipate the heat generated in the bulb. Second, higher power densities may be achieved within a dielectric waveguide than are possible in the plasma lamps with air cavities that are currently used in the art. The energy density of a dielectric waveguide is greater, depending on the dielectric constant of the material used for the waveguide, than the energy density of an air cavity plasma lamp.

Referring back to the DWIPL 101 of FIG. 1, high resonant energy within the waveguide 103, corresponding to a high value for Q (where Q is the ratio of the operating frequency to the frequency width of the resonance) for the waveguide results in a high evanescent leakage of microwave energy into the bulb cavity 105. High leakage in the bulb cavity 105 leads to the quasi-static breakdown of the noble gas within the envelope 127, thus generating the first free electrons. The oscillating energy of the free electrons scales as $I\lambda^2$, where I is the circulating intensity of the microwave energy and λ is the wavelength of that energy. Therefore, the higher the microwave energy, the greater is the oscillating energy of the free electrons. By making the oscillating energy greater than the ionization potential of the gas, electron-neutral collisions result in efficient build-up of plasma density.

Once the plasma is formed in the DWIPL and the incoming power is absorbed, the waveguide's Q value drops due to the conductivity and absorption properties of the plasma. The drop in the Q value is generally due to a change in the impedance of the waveguide. After plasma formation, the presence of the plasma in the cavity makes the bulb cavity absorptive to the resonant energy, thus changing the overall impedance of the waveguide. This change in impedance is effectively a reduction in the overall reflectivity of the waveguide. Therefore, by matching the reflectivity of the feed close to the reduced reflectivity of the

waveguide, a sufficiently high Q value may be obtained even after the plasma formation to sustain the plasma. Consequently, a relatively low net reflection back into the energy source may be realized.

5 Much of the energy absorbed by the plasma eventually appears as heat, such that the temperature of the lamp may approach 1000 °C. When the waveguide is also used as a heat sink, as previously described, the dimensions of the waveguide may change due to its coefficient of thermal expansion. Under such circumstances, when the waveguide expands, the microwave frequency that resonates within the waveguide changes and resonance is lost. In order for
10 resonance to be maintained, the waveguide preferably has at least one dimension equal to an integer multiple of the half wavelength microwave frequency being generated by the microwave source.

One preferred embodiment of a DWIPL that compensates for this change in dimensions employs a waveguide comprising a dielectric material having a
15 temperature coefficient for the refractive index that is approximately equal and opposite in sign to its temperature coefficient for thermal expansion. Using such a material, a change in dimensions due to thermal heating offsets the change in refractive index, minimizing the potential that the resonant mode of the cavity would be interrupted. Such materials include Titanates. A second embodiment
20 that compensates for dimensional changes due to heat comprises physically tapering the walls of the waveguide in a predetermined manner.

In another preferred embodiment, schematically shown in FIG. 6, a DWIPL 610 may be operated in a dielectric resonant oscillator mode. In this mode, first and second microwave feeds 613, 615 are coupled between the dielectric
25 waveguide 611, which may be of any shape previously discussed, and the microwave energy source 617. The energy source 617 is preferably broadband with a high gain and high power output and capable of driving plasma to emission.

The first feed 613 may generally operate as described above in other embodiments. The second feed 615 may probe the waveguide 611 to sample the
30 field (including the amplitude and phase information contained therein) present and provide its sample as feedback to an input of the energy source 617 or amplifier. In probing the waveguide 611, the second feed 615 also preferably acts to filter out stray frequencies, leaving only the resonant frequency within the waveguide 611.

35 In this embodiment, the first feed 613, second feed, 615 and bulb cavity 619 are each preferably positioned with respect to the waveguide 611 at locations

where the electric field is at a maximum. Using the second feed 615, the energy source 617 amplifies the resonant energy within the waveguide 611. The source 617 thereby adjusts the frequency of its output to maintain one or more resonant modes in the waveguide 611. The complete configuration thus forms a resonant oscillator. In this manner, automatic compensation may be realized for frequency shifts due to plasma formation and thermal changes in dimension and the dielectric constant.

The dielectric resonant oscillator mode also enables the DWIPL 610 to have an immediate re-strike capability after being turned off. As previously discussed, the resonant frequency of the waveguide 611 may change due to thermal expansion or changes in the dielectric constant caused by heat generated during operation. When the DWIPL 610 is shutdown, heat is slowly dissipated, causing instantaneous changes in the resonant frequency of the waveguide 611.

However, as indicated above, in the resonant oscillator mode the energy source 617 automatically compensates for changes in the resonant frequency of the waveguide 611. Therefore, regardless of the startup characteristics of the waveguide 611, and providing that the energy source 617 has the requisite bandwidth, the energy source 617 will automatically compensate to achieve resonance within the waveguide 611. The energy source immediately provides power to the DWIPL at the optimum plasma-forming frequency.

While embodiments and advantages of this invention have been shown and described, it would be apparent to those skilled in the art that many more modifications are possible without departing from the inventive concepts herein. The invention, therefore, is not to be restricted except in the spirit of the appended claims.

Claims

1. A lamp comprising:
 - (a) a waveguide having a body comprising a dielectric material, said waveguide configured to be connected to an energy source for receiving
5 electromagnetic energy; and
 - (b) a bulb coupled to the waveguide and containing a gas-fill that emits light when receiving the electromagnetic energy from the waveguide.
2. The lamp of claim 1, wherein the body of the waveguide includes an outer coating comprising an electrically conductive material.
- 10 3. The lamp of claim 1, wherein the bulb comprises a cavity in the body of the waveguide, and a window coupled to and covering the cavity.
4. The lamp of claim 3, wherein the window is substantially transparent to the emitted light.
5. The lamp of claim 3, wherein the window is comprised of sapphire.
- 15 6. The lamp of claim 3, wherein the window comprises a focusing lens.
7. The lamp of claim 1, wherein the body of the waveguide includes a cavity, and the bulb is at least in part positioned in the cavity.
8. The lamp of claim 7, wherein the bulb comprises a ceramic enclosure coupled to a sapphire window.
- 20 9. The lamp of claim 7, wherein the body of the waveguide includes a main part and a protrusion from the main part, and the cavity is positioned in the protrusion.
10. The lamp of claim 3, wherein the body of the waveguide includes a main part and a protrusion from the main part, and the cavity is positioned in the

11. The lamp of claim 1, further comprising a first energy feed coupled to the waveguide for receiving the electromagnetic energy.

12. The lamp of claim 1, wherein the light is visible, infrared, or ultra violet-light.

5 13. The lamp of claim 1, wherein the dielectric material has a dielectric constant greater than approximately 2.0.

14. The lamp of claim 1, wherein the electromagnetic energy has a frequency between about 0.5 and about 10 GHz.

10 15. The lamp of claim 1, wherein the walls of the bulb are at least partially reflective of the light.

16. The lamp of claim 1, wherein the walls of the bulb are shaped to reflect the light towards the window.

17. The lamp of claim 1, wherein the walls of the bulb comprise a dielectric material.

15 18. The lamp of claim 1, wherein the dielectric material is a ceramic.

19. The lamp of claim 1, wherein the walls of the bulb thermally isolate the bulb from the waveguide.

20. The lamp of claim 1, wherein the window and the walls of the bulb have approximately equal thermal expansion coefficients.

20 21. The lamp of claim 2, wherein the outer coating of the waveguide is thermally conductive.

22. The lamp of claim 1, further comprising a heat sink connected to an outer surface of the waveguide.

23. The lamp of claim 1, wherein the waveguide has a rectangular prism-like shape.

24. The lamp of claim 1, wherein the waveguide has cylindrical prism-like shape.

5 25. The lamp of claim 1, wherein the waveguide is sphere-like in shape.

26. The lamp of claim 1, further comprising an energy feed coupled to the waveguide for receiving the electromagnetic energy, wherein a positive force mechanism maintains constant contact between the first energy feed and the waveguide.

10 27. The lamp of claim 1, wherein the energy source is thermally isolated from the waveguide and the bulb.

28. The lamp of claim 1, wherein the gas-fill comprises a noble gas and a metal halide.

15 29. The lamp of claim 1, further comprising a thermal isolation layer disposed between the bulb and the waveguide.

30. The lamp of claim 29, wherein the thermal isolation layer comprises an evacuated space.

31. The lamp of claim 1, wherein an electromagnetic field resonates within the waveguide and includes at least one resonant maximum.

20 32. The lamp of claim 31, further comprising a first energy feed coupled to the waveguide for receiving the electromagnetic energy, wherein the bulb and the first energy feed are proximate to one of the at least one resonant maximum.

33. The lamp of claim 31, further comprising a first energy feed coupled to the waveguide for receiving the electromagnetic energy, wherein the

and the bulb is positioned at a second maximum of the at least two resonant maxima.

34. The lamp of claim 31, further comprising first and second energy feeds coupled to the waveguide for receiving the electromagnetic energy, wherein
5 the electromagnetic field includes at least one resonant maxima and the bulb and the first energy feed are proximate to one of the at least one resonant maximum.

35. The lamp of claim 31, further comprising the energy source and a feedback mechanism coupled between the waveguide and the energy source, wherein the feedback mechanism samples the electromagnetic field within the
10 waveguide, transmits the sampled field to the energy source, and the energy source adjusts its delivery of electromagnetic energy to maximize the electromagnetic field detected by the feedback mechanism.

36. The lamp of claim 35, further comprising a first energy feed coupled between the energy source and the waveguide, wherein the electromagnetic
15 energy includes at least one resonant maximum and the first energy feed is positioned approximately at a maximum of the at least one resonant maximum and the bulb is positioned approximately at a maximum of the at least one resonant maximum.

37. The lamp of claim 1 further comprising the energy source.

20 38. A lamp comprising:
a waveguide comprising a dielectric material and being thermally isolated from and configured to receive electromagnetic energy from an energy source, said waveguide having a protrusion on a first side defining a bulb cavity and an electrically and thermally conductive outer coating on an outer surface of
25 the waveguide except the surface defining the protrusion;
a bulb containing a gas-fill that produces light when receiving the electromagnetic energy, said bulb being at least in part disposed in the bulb cavity and comprising:
(a) a window, the window being substantially transparent to the

- (b) an outer wall, the outer wall being hermetically coupled with the window, shaped to direct the light towards the window, and having a thermal expansion coefficient approximately equal to the thermal expansion coefficient of the window, wherein the window and the outer wall define an envelope containing the gas-fill; and
- 5 (c) a heat sink coupled to the outer surface of the waveguide.

39. The lamp of claim 38, wherein the electromagnetic energy resonates within the waveguide and comprises at least one resonant maximum, and wherein the bulb cavity and an input of the electromagnetic energy to the waveguide are proximate to the at least one resonant maximum.

10

40. A lamp comprising:
- first and second energy feeds for receiving electromagnetic energy from an energy source;
- a waveguide having a body comprising a dielectric material, said
- 15 waveguide being coupled to and for receiving electromagnetic energy from the first energy feed and the second energy feed, having a bulb cavity, and an electrically and thermally conductive coating on the surfaces of the body except the surfaces defining the cavity;
- a bulb containing a gas-fill, said bulb being disposed in the bulb
- 20 cavity and comprising a window, the window being substantially transparent to emitted light, and an outer wall, the outer wall being hermetically coupled with the window, shaped to direct the light towards the window, and having a thermal expansion coefficient approximately equal to the thermal expansion coefficient of the window, wherein the window and the outer wall define an envelope of the bulb
- 25 to contain the gas-fill; and
- a heat sink coupled to the surface of the waveguide.

41. The lamp of claim 40, wherein the waveguide is configured to contain resonant electromagnetic energy that comprises at least three resonant maxima, the first energy feed being proximate to a first resonant maximum, the

30 second energy feed being proximate to a second resonant maximum, and the cavity being proximate to a third resonant maximum.

a high frequency electromagnetic energy source having an output port and a feedback port;

an energy feed coupled to the output port to receive electromagnetic energy from the energy source;

5 a waveguide having a body comprising a dielectric material, said waveguide being coupled to and receiving electromagnetic energy from the energy feed, having a bulb cavity in the body and a reflective outer coating;

a feedback mechanism coupled between the feedback port and the waveguide, the feedback mechanism for sampling the electromagnetic energy
10 within the waveguide and for communicating amplitude and phase of the electromagnetic energy to the energy source, the energy source adjusting its output of electromagnetic energy to maximize the electromagnetic energy detected by the feedback mechanism;

a bulb containing a gas-fill that produces light when excited by the
15 electromagnetic energy, said bulb being disposed in the cavity;

a heat sink coupled to a side of the waveguide.

43. The lamp of claim 42, wherein the electromagnetic energy within the waveguide comprises at least one resonant maximum, the energy feed being positioned at one of the at least one resonant maximum, the feedback mechanism
20 being positioned to sample the resonant field, and the bulb cavity being positioned at one of the at least one resonant maximum.

44. A lamp comprising:

at least one energy feed for receiving electromagnetic energy from an energy source;

25 a waveguide comprising a dielectric material and coupled to the at least one energy feed for receiving electromagnetic energy, said waveguide having a plurality of separate cavities, and an electrically and thermally conductive outer coating deposited on the outer surfaces of the dielectric except the surfaces comprising the plurality of bulb cavities;

30 a plurality of bulbs containing a noble gas and a light emitter that outputs light when excited by the electromagnetic energy, wherein each of the plurality of bulbs is disposed in one of the plurality of bulb cavities and comprises

approximately equal to the thermal expansion coefficient of the window, the inner wall being hermetically coupled to the window, the window and the interior wall thereby defining an envelope in which the material is contained; and

5 a plurality of heat sinks coupled to all sides of the waveguide, said plurality of heat sinks positioned to dissipate heat from the waveguide.

45. The lamp of claim 44, wherein the electromagnetic energy is resonant within the waveguide and comprises a plurality of energy maxima, the at least one energy feed being positioned approximately at at least one of the plurality of energy maxima.

10 46. A lamp comprising:
an electromagnetic energy source;
an energy feed coupled to and receiving electromagnetic energy
from the energy source;
a dielectric waveguide thermally isolated from the energy source and
15 coupled to and receiving electromagnetic energy from the energy feed, said waveguide having a cavity and an electrically and thermally conductive outer coating the outer surface of the dielectric material except the surface defining the cavity;
a thermal isolation layer lining the cavity;
20 a bulb containing a material that produces light when excited by the electromagnetic energy, said bulb being disposed in the cavity, with the thermal isolation layer separating the bulb from the waveguide, and comprising a window, the window being transparent to the light, and an inner wall, the inner wall being hermetically coupled to the window shaped to direct the light towards the window,
25 and having a thermal expansion coefficient approximately equal to the thermal expansion coefficient of the window, the window and the inner wall defining an envelope in which the material is contained; and
a heat sink coupled to an outer surface of the waveguide.

47. The lamp of claim 46, wherein the electromagnetic energy resonates
30 within the waveguide and comprises at least one resonant maximum, the energy feed and the bulb cavity being proximate to the at least one resonant maximum.

48. The lamp of claim 46, wherein the thermal isolation layer comprises an evacuated space.

49. The lamp of claim 46, wherein the thermal isolation layer comprises a second dielectric material.

- 5 50. A method for producing light comprising the steps of:
- (a) generating electromagnetic energy;
 - (b) directing the electromagnetic energy into a dielectric waveguide having a cavity;
 - (c) directing the electromagnetic energy into an envelope defined
 - 10 by the cavity and a window, the envelope containing a gas-fill; and
 - (d) exciting the gas-fill into producing light.

51. The method of claim 50 further comprising the step of directing the produced light through the window.

- 15 52. The method of claim 50, further comprising the step of dissipating the heat generated by the plasma through the outer surface of the waveguide.

53. The method of claim 50, comprising the steps of:
- (e) sampling the levels of electromagnetic energy within the waveguide, and
 - (f) adjusting the frequency of the electromagnetic energy
 - 20 generated until the sampled electromagnetic energy is at a maximum.

54. 54. The method of claim 50, further comprising the step of generating electromagnetic resonance within the waveguide.

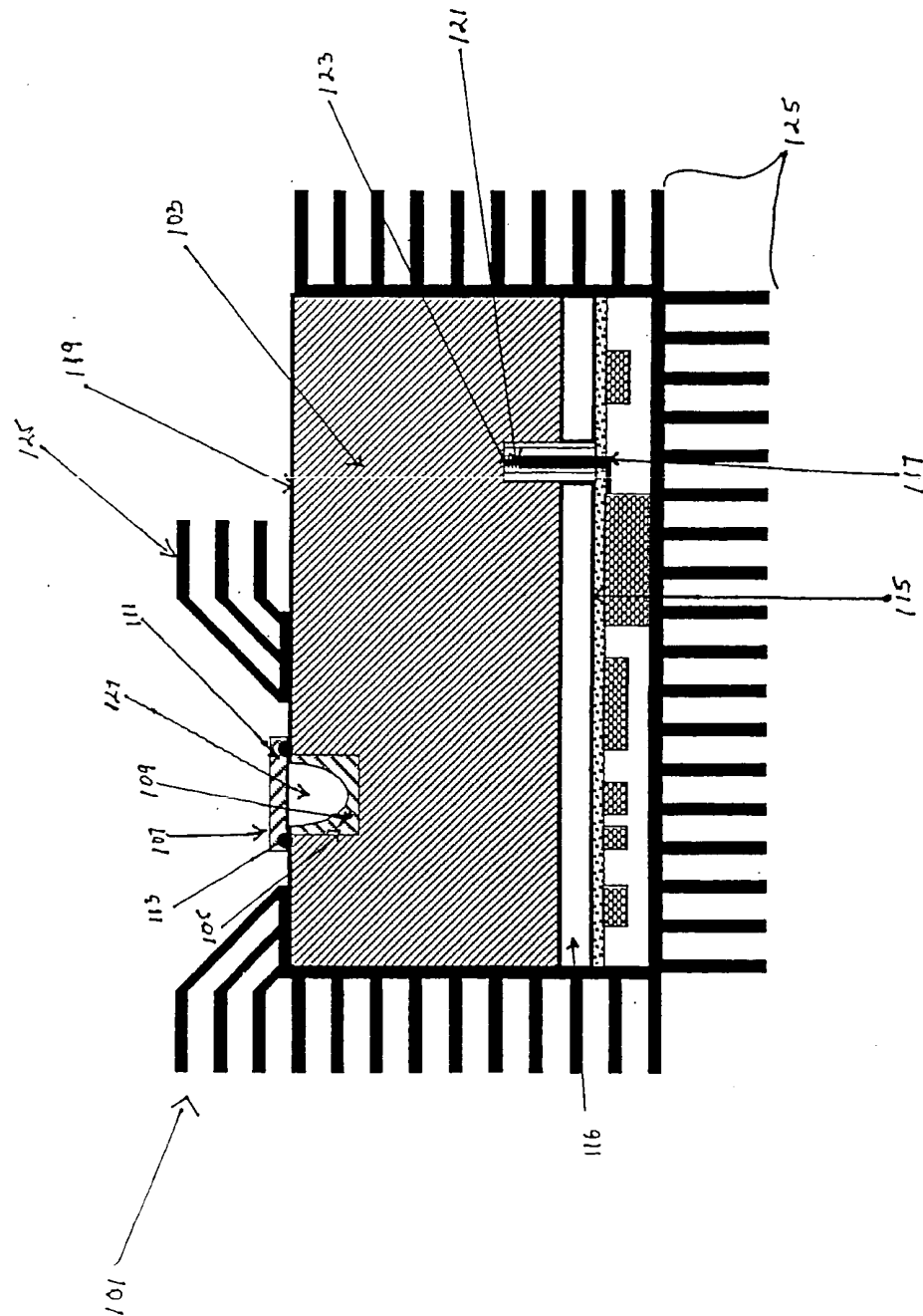
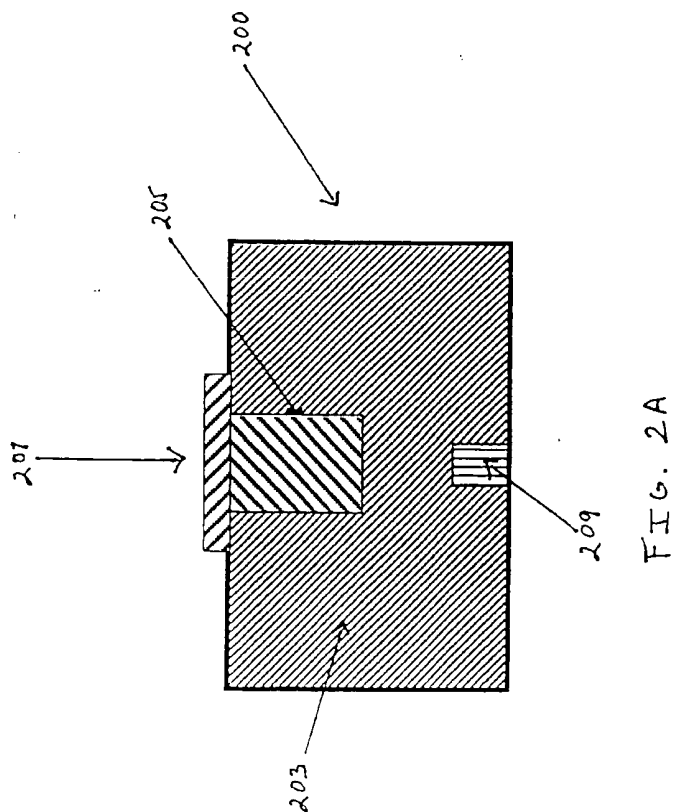
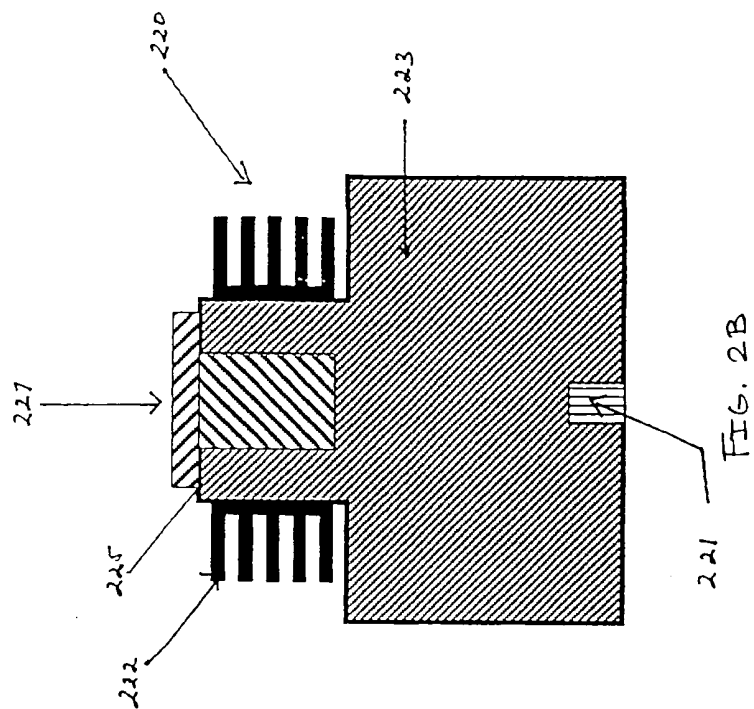


FIG. 1

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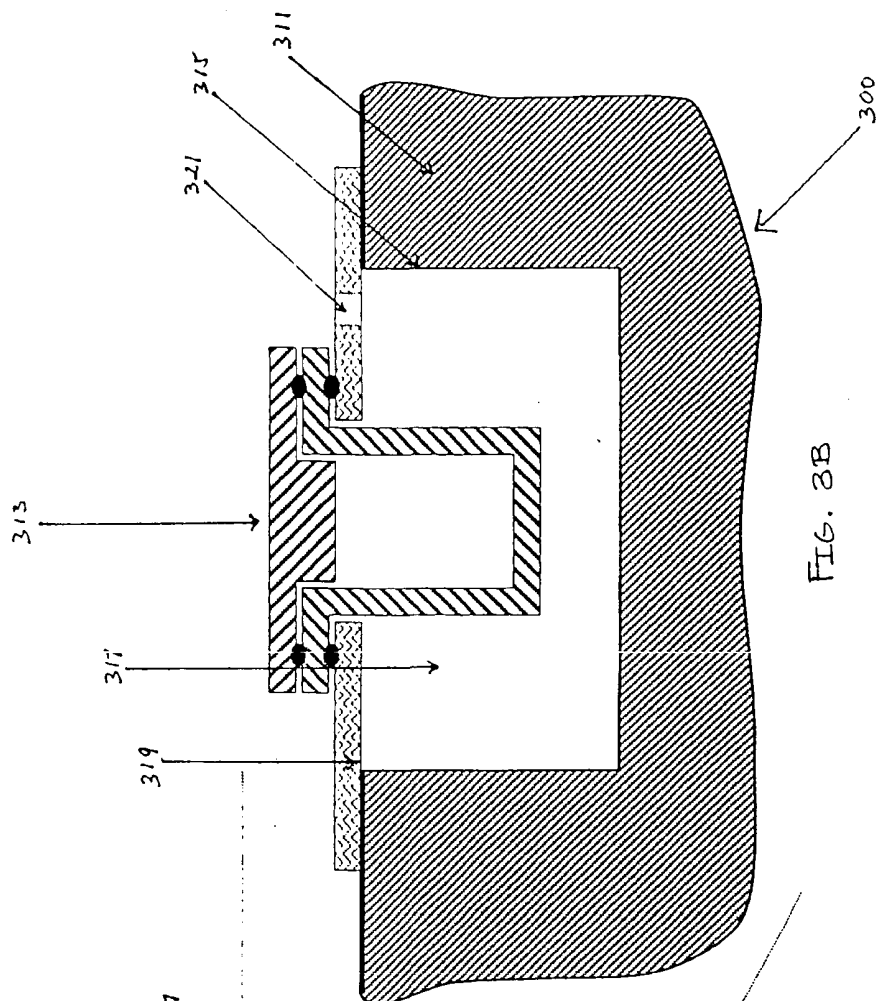


FIG. 3B

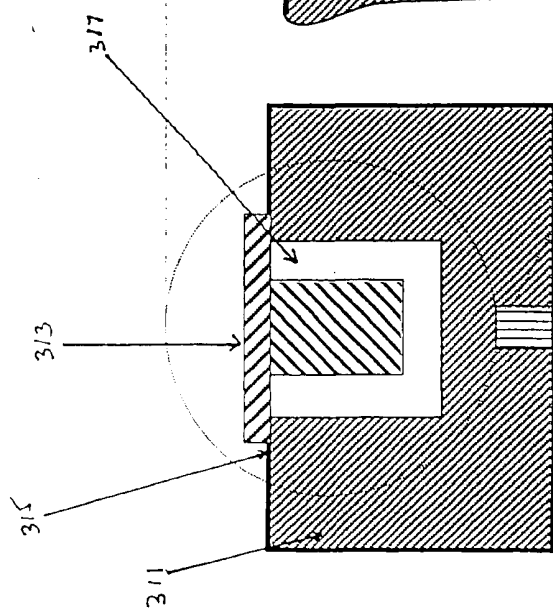
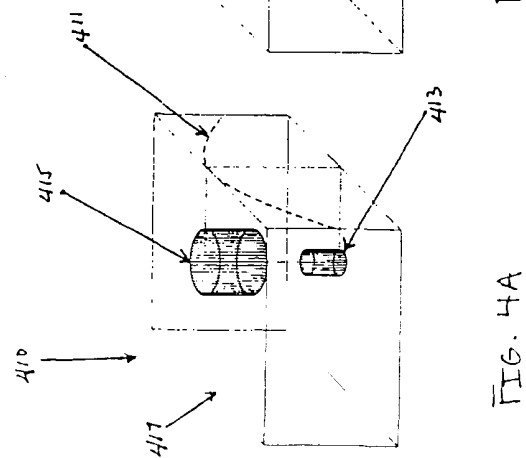
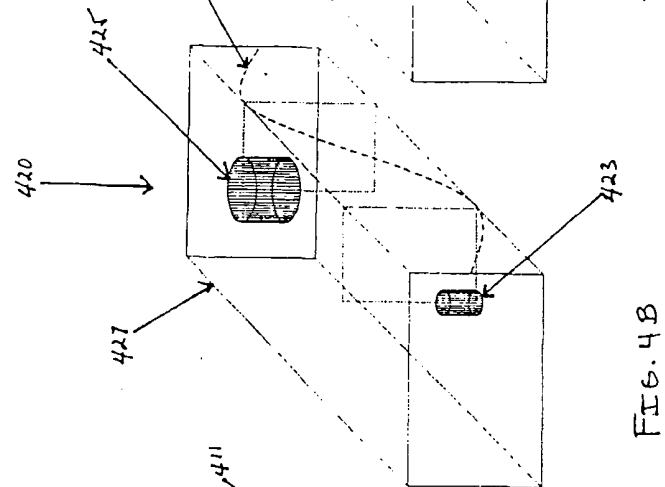
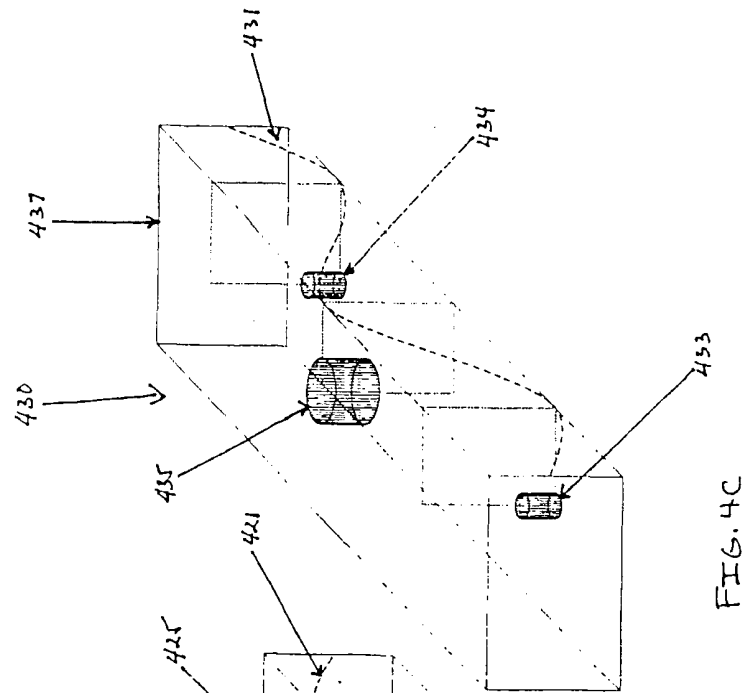


FIG. 3A

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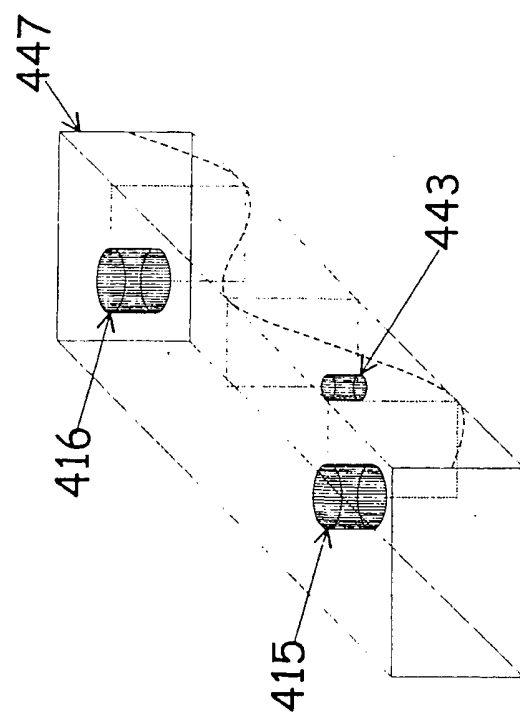
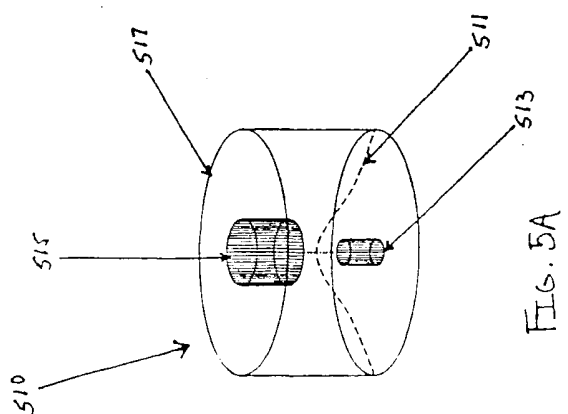
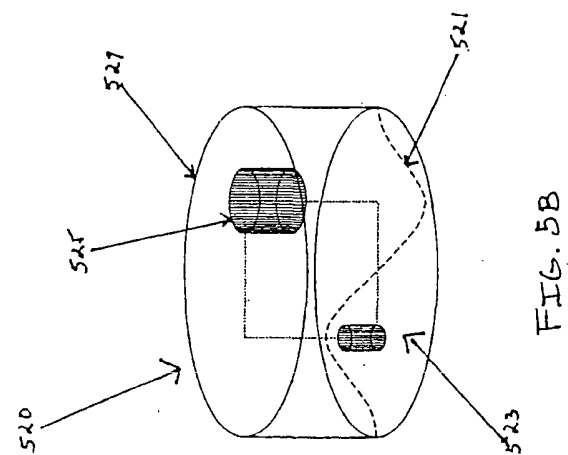
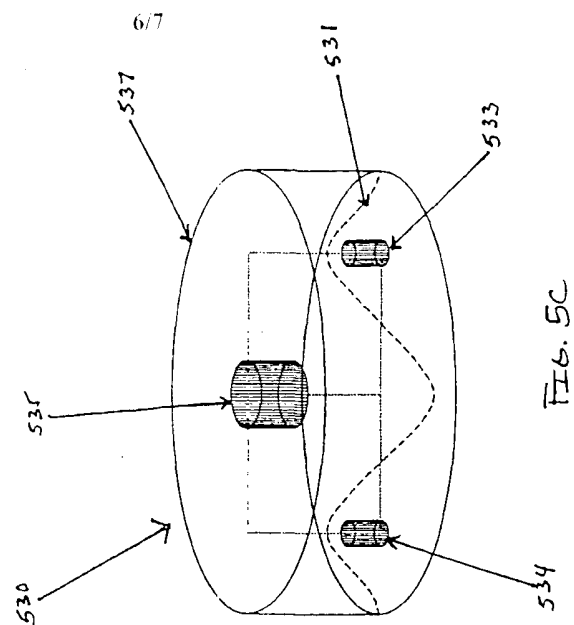


Fig. 4D



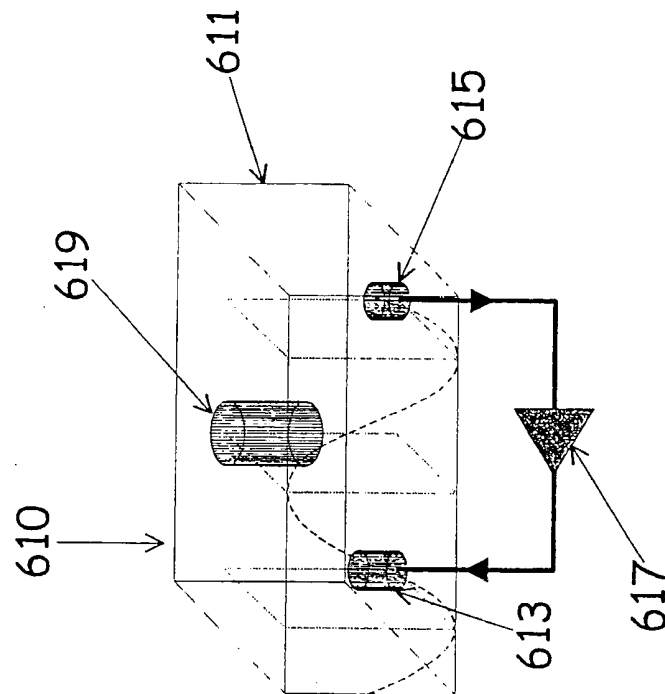


Fig. 6

INTERNATIONAL SEARCH REPORT

International Application No.

PCT/US 01/23745

A. CLASSIFICATION OF SUBJECT MATTER
IPC 7 H01J65/04

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)

IPC 7 H01J

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

WPI Data, PAJ, EPO-Internal

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
Y	EP 0 035 898 A (MITSUBISHI ELECTRIC CORP) 16 September 1981 (1981-09-16) the whole document	1
A	---	2-54
Y	DE 195 32 780 A (PATES TECH PATENTVERWERTUNG) 13 March 1997 (1997-03-13) abstract	1
A	---	38,40, 42,44, 46,50
A	EP 0 419 947 A (SIEMENS AG) 3 April 1991 (1991-04-03) abstract	1, 38,40, 42,44, 46,50

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☒ Further documents are listed in the continuation of box C.

☒ Patent family members are listed in annex.

* Special categories of cited documents

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Date of the actual completion of the international search

27 November 2001

Date of mailing of the international search report

05/12/2001

INTERNATIONAL SEARCH REPORT

International Application No.

PCT/US 01/23745

C.(Continuation) DOCUMENTS CONSIDERED TO BE RELEVANT		
Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
A	US 4 887 192 A (KAMAREHI MOHAMMED ET AL) 12 December 1989 (1989-12-12) the whole document ---	1-54
A	US 6 031 333 A (SIMPSON JAMES E) 29 February 2000 (2000-02-29) cited in the application the whole document ---	1-54
A	US 5 841 242 A (KAMAREHI MOHAMMAD ET AL) 24 November 1998 (1998-11-24) cited in the application the whole document ---	1-54
A	WO 98 23133 A (FUSION LIGHTING INC ;SIMPSON JAMES (US)) 28 May 1998 (1998-05-28) cited in the application abstract ---	1-54
A	WO 96 28840 A (FUSION LIGHTING INC) 19 September 1996 (1996-09-19) cited in the application the whole document ---	1-54
A	WO 95 12222 A (FUSION LIGHTING INC) 4 May 1995 (1995-05-04) cited in the application claims 1-15; figures 1-11 ---	1-54
A	DE 33 18 795 A (FUSION SYSTEMS CORP) 15 December 1983 (1983-12-15) cited in the application abstract; figures 1,2 -----	1-54

INTERNATIONAL SEARCH REPORT

Information on patent family members

International Application No

PCT/US 01/23745

Patent document cited in search report		Publication date	Patent family member(s)	Publication date
EP 0035898	A	16-09-1981	JP 56126250 A	03-10-1981
			CA 1197549 A1	03-12-1985
			DE 3177071 D1	20-07-1989
			EP 0035898 A1	16-09-1981
			HK 10790 A	16-02-1990
			SG 490 G	06-07-1990
			US 4498029 A	05-02-1985
			US RE32626 E	22-03-1988
DE 19532780	A	13-03-1997	DE 19532780 A1	13-03-1997
			CN 1148279 A	23-04-1997
			WO 9709748 A1	13-03-1997
			EP 0848860 A1	24-06-1998
			HR 960407 A1	31-08-1997
			ZA 9607040 A	14-07-1997
EP 0419947	A	03-04-1991	DE 59008580 D1	06-04-1995
			EP 0419947 A2	03-04-1991
			JP 3123305 A	27-05-1991
			US 5077822 A	31-12-1991
US 4887192	A	12-12-1989	DE 3935058 A1	10-05-1990
			JP 2183904 A	18-07-1990
			JP 2583619 B2	19-02-1997
US 6031333	A	29-02-2000	AU 5563796 A	07-11-1996
			EP 0821832 A1	04-02-1998
			JP 11511892 T	12-10-1999
US 5841242	A	24-11-1998	US 5404076 A	04-04-1995
			US 5977724 A	02-11-1999
			US 5834895 A	10-11-1998
			US 5606220 A	25-02-1997
			US 5757130 A	26-05-1998
			DE 4241911 A1	17-06-1993
			JP 5290608 A	05-11-1993
			AT 151201 T	15-04-1997
			AU 662889 B2	21-09-1995
			AU 8925191 A	26-05-1992
			BR 9107033 A	22-03-1994
			CA 2093921 A1	26-04-1992
			DE 69125499 D1	07-05-1997
			DE 69125499 T2	17-07-1997
			DK 554350 T3	22-09-1997
			EP 0554350 A1	11-08-1993
			ES 2101759 T3	16-07-1997
			GR 3023695 T3	30-09-1997
			HU 214794 B	28-05-1998
			HU 65057 A2	28-03-1994
			JP 3078523 B2	21-08-2000
			JP 10228886 A	25-08-1998
			JP 2931819 B2	09-08-1999
			JP 6132018 A	13-05-1994
			KR 237859 B1	15-01-2000
			RU 2130014 C1	10-05-1999

INTERNATIONAL SEARCH REPORT

Information on patent family members

International Application No

PCT/US 01/23745

Patent document cited in search report		Publication date	Patent family member(s)	Publication date
US 5841242	A		US 6020676 A	01-02-2000
			US 5798611 A	25-08-1998
			US 5661365 A	26-08-1997
			US 5670842 A	23-09-1997
			US 5804922 A	08-09-1998
			US 5773918 A	30-06-1998
			US 5866980 A	02-02-1999
			US 5682080 A	28-10-1997
			US 5925981 A	20-07-1999
WO 9823133	A	28-05-1998	US 5910710 A	08-06-1999
			AU 5260898 A	10-06-1998
			EP 0940062 A1	08-09-1999
			JP 2001504634 T	03-04-2001
			WO 9823133 A1	28-05-1998
WO 9628840	A	19-09-1996	US 5594303 A	14-01-1997
			AT 208960 T	15-11-2001
			CA 2214891 A1	19-09-1996
			EP 0819317 A1	21-01-1998
			HU 9800281 A2	29-06-1998
			JP 11503263 T	23-03-1999
			WO 9628840 A1	19-09-1996
WO 9512222	A	04-05-1995	US 5448135 A	05-09-1995
			CA 2173489 A1	04-05-1995
			EP 0725984 A1	14-08-1996
			HU 74338 A2	30-12-1996
			JP 9504407 T	28-04-1997
			WO 9512222 A1	04-05-1995
DE 3318795	A	15-12-1983	US 4485332 A	27-11-1984
			US 4507587 A	26-03-1985
			DE 3318795 A1	15-12-1983
			DE 8315211 U1	20-11-1986
			JP 1883961 C	10-11-1994
			JP 4014480 B	12-03-1992
			JP 59086153 A	18-05-1984
			JP 1698221 C	28-09-1992
			JP 3049102 A	01-03-1991
			JP 3061282 B	19-09-1991
			US 4695757 A	22-09-1987
			US 4954755 A	04-09-1990
			US 4749915 A	07-06-1988